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Docket No.: 055071-0310

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Armin LIEBCHEN

Confirmation Number: 3610

Application No.: 10/705,234

Group Art Unit: 2851

Filed: November 12, 2003

Examiner: Peter B. Kim

For: METHOD AND APPARATUS FOR PROVIDING LENS ABERRATION COMPENSATION BY

ILLUMINATION SOURCE OPTIMIZATION

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed under Rule 37 CFR 1.97(i), wherein applicants are submitting references and the Search and Examination Reports before the grant of a patent to be placed in the file.

Accordingly, copies of the references as listed on the attached Form PTO-1449 are submitted herewith for placement in the file. No certification or fees are deemed necessary.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: February 7, 2006

Please recognize our Customer No. 20277 as our correspondence address.



SHEET 1 OF 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION					ATTY. DOCKET NO. 055071-0310		SERIAL NO 10/705,2				
					APPLICANT Armin LIEBCHEN						
(PTO-1449)					FILING DATE November 12, 2	FILING DATE November 12, 2003 GROUP 2851					
U.S. PATENT DOCUMENTS											
EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (4 known)		Publication Dat MM-DD-YYYY		Name of Patentee or Applicant of Cited Document			Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US									
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FOREIGN PATENT DOCUMENTS											
EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes -Number 4 -Kind Codes (if known)		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear		Translation Yes No			
		E	P 1 217 448 A2	06/26/2002	HITACHI, LTD.			Х			
			JP 07-111239	04/25/1995	CANON INC CANON SALES CO INC.			English Translation of JAPAN			
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)											
EXAMINER'S INITIALS	CITE NO.										
											
		<u> </u>									
EXAMINER						DATE CONSIDERED					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.